



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 2221

Myounggoo LEE et al.

Group Art Unit: 1753

Application No.: 10/658,460

Examiner: R.G. McDonald

Filed: September 10, 2003

Attorney Docket No.: 029567-00004

For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING  
FILM FORMING APPARATUS

**REQUEST TO CHANGE DOCKET NUMBER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 2, 2007

Sir:

It is respectfully requested that the records of the U.S. Patent and Trademark Office be updated for the above-identified patent application to change the docket number from 101136-00095 to Docket Number 029567-00004.

The Commissioner is hereby authorized to charge any fee deficiency or credit any overpayment associated with this communication to Deposit Account No. 01-2300, referencing our Docket Number 029567-00004.

Respectfully submitted,

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